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Attorney Docket No. 54008.8100.US00  
P01-0015

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KENNY, Michael et al.

Serial No.: 09/925,884 ✓

Filed: August 6, 2001 ✓

For: Process And Apparatus For Treating  
A Workpiece Such As A Semiconductor  
Wafer

) Group Art Unit: 1746

) Examiner: Z. El-Arini

10/12  
4/29/13

AMENDMENT UNDER 37 C.F.R. §1.111

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In reply to the Office Action mailed on January 17, 2003, please amend the application as follows:

IN THE SPECIFICATION

Please amend the Title of the Invention as indicated in the attached replacement specification sheet.

CERTIFICATE OF MAILING  
(37 C.F.R. §1.8a)

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as First Class Mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

April 14, 2003  
Date of Deposit

Debbie Gilbert  
Debbie Gilbert

LA030450.078